

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

SAH
2
11-26-01
j1046 U.S. PTO
09/966651
09/28/01

Inventor: Zhu, Wang
Title: High Frequency Electrochemical Deposition
Filing date: 2001.09.28
Express mail number: EL 872 412 144 US
Attorney docket: 01-446

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97

Assistant Commissioner for Patents
Washington DC 20231


Sir:

The enclosed documents are submitted in compliance with 37 C.F.R. §§ 1.97 and 1.98. Also enclosed is a form PTO-1449 listing the citations. By this submission Applicant is not admitting the materiality of these citations; they are merely submitted to ensure full compliance with 37 C.F.R. § 1.56.

Sincerely,

LUEDEKA, NEELY & GRAHAM, P.C.

By:


Rick Barnes, 39,596

2001.09.28
P.O. Box 1871
Knoxville TN 37901

T:1.865.546.4305
F:1.865.523.4478

RBarnes@LNG-Patent.com